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| Search Notes  | Application/Control No. 10580698 | Applicant(s)/Patent Under Reexamination FIOLKA ET AL. |
| | Examiner Jade R. Chwasz | Art Unit 2872 |

| SEARCHED | | | |
|----------|----------|---------|----------|
| Class | Subclass | Date | Examiner |
| 359 | 489 | 11/5/08 | JRC |

| SEARCH NOTES | | |
|---|----------|----------|
| Search Notes | Date | Examiner |
| Inventor name search | 11/5/08 | JRC |
| Information disclosure statement review | 11/5/08 | JRC |
| 359/483,485,487,488,489,494-497,500,501 with text in EAST | 11/5/08 | JRC |
| Text search in EAST | 11/5/08 | JRC |
| Consulted with Primary Arnel Lavarias | 11/13/08 | JRC |
| Updated search | 3/16/09 | JRC |
| Consulted with Primary Arnel Lavarias | 3/30/09 | JRC |
| Updated search | 6/9/09 | JRC |
| Information disclosure statement review | 6/9/09 | JRC |
| Consulted with Primary Arnel Lavarias | 6/10/09 | JRC |
| Updated search | 11/2/09 | JRC |
| Consulted with Primary Arnel Lavarias | 11/2/09 | JRC |
| Information disclosure statement review | 1/20/10 | JRC |
| Consulted with Primary Arnel Lavarias | 1/20/10 | JRC |
| Information disclosure statement review | 3/24/10 | JRC |
| Consulted with Primary Arnel Lavarias | 3/24/10 | JRC |
| Information disclosure statement review | 4/23/10 | JRC |
| Consulted with Primary Arnel Lavarias | 4/23/10 | JRC |
| Information disclosure statement review | 6/24/10 | JRC |
| Consulted with Primary Arnel Lavarias | 6/24/10 | JRC |
| Information disclosure statement review | 8/23/10 | JRC |
| Consulted with Primary Arnel Lavarias | 8/23/10 | JRC |
| Information disclosure statement review | 11/1/10 | JRC |
| Consulted with Primary Arnel Lavarias | 11/1/10 | JRC |

| INTERFERENCE SEARCH | | | |
|---------------------|------------------------------------|---------|----------|
| Class | Subclass | Date | Examiner |
| | Interference search (see attached) | 3/19/09 | JRC |
| | Interference search (see attached) | 11/2/09 | JRC |

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